IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Marco Wedowski et al.

Serial No.: 10/598,481

Filed: June 18, 2007

Art Unit: 2837

Examiner: Unknown

Conf. No.: 5997

Title : METHODS FOR MANUFACTURING REFLECTIVE OPTICAL ELEMENTS,

REFLECTIVE OPTICAL ELEMENTS, EUV-LITHOGRAPHY APPARATUSES

AND METHODS FOR OPERATING OPTICAL ELEMENTS AND EUV-LITHOGRAPHY APPARATUSES, METHODS FOR DETERMINING THE

PHASE SHIFT, METHODS FOR...

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

Please correct the title to read as:

--METHODS FOR MANUFACTURING REFLECTIVE OPTICAL ELEMENTS, REFLECTIVE OPTICAL ELEMENTS, EUV-LITHOGRAPHY APPARATUSES AND METHODS FOR OPERATING OPTICAL ELEMENTS AND EUV-LITHOGRAPHY APPARATUSES, METHODS FOR DETERMINING THE PHASE SHIFT, METHODS FOR DETERMINING THE LAYER THICKNESS, AND APPARATUSES FOR CARRYING OUT THE METHODS--

Please supply a corrected Filing Receipt to the undersigned with respect to this application. A copy of the original Filing Receipt showing the desired changes is attached for your convenience.

No fee is believed to be due. If, however, there are any charges or credits, please apply them to Deposit Account No. 06-1050.

Respectfully submitted,

Date: January 14, 2008 /Sean P. Daley/

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26161 FISH & RICHARDSON PC P.O. BOX 1022 MINNEAPOLIS, MN 55440-1022 CONFIRMATION NO. 5997 CORRECTED FILING RECEIPT

Date Mailed: 11/06/2007

Receipt is acknowledged of this non-provisional patent application. The application will be taken up for examination in due course. Applicant will be notified as to the results of the examination. Any correspondence concerning the application must include the following identification information: the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filling Receipt, please write to the Office of Initial Patent Examination's Filling Receipt Corrections. Please provide a copy of this Filling Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filling Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filling Receipt Incorporating the requested corrections

Applicant(s)

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Assignment For Published Patent Application

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Domestic Priority data as claimed by applicant

This application is a 371 of PCT/EP05/50985 03/04/2005 which claims benefit of 60/550,302 03/05/2004

Foreign Applications

GERMANY 10 2004 011 356.4 03/05/2004 GERMANY 10 2004 011 355.6 03/05/2004

If Required, Foreign Filing License Granted: 09/01/2007

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US 10/598,481**

Projected Publication Date: 12/13/2007

page 1 of 3

Non-Publication Request: No

Early Publication Request: No

Title

Methods

Method For Manufacturing Reflective Optical Element, Reflective Optical Elements, Euv-Lithography Apparatuses And Methods For Operating Optical Elements And Euv-Lithography Apparatuses, Methods For Determining The Phase Shift, Methods For Determining The Layer Thickness, And Apparatuses For Carrying Out The Methods

Preliminary Class

355

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Title 37, Code of Federal Regulations, 5.11 & 5.15

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